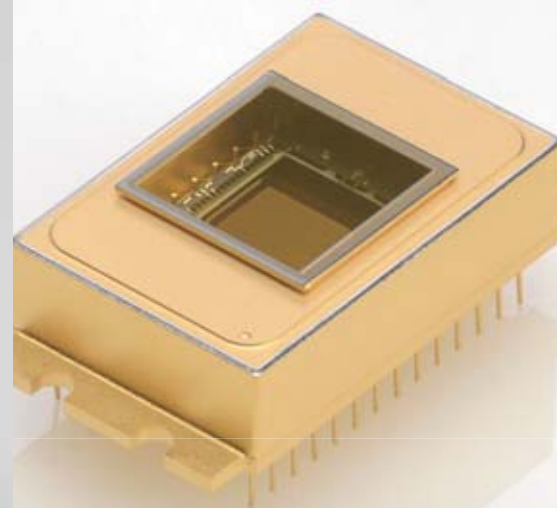
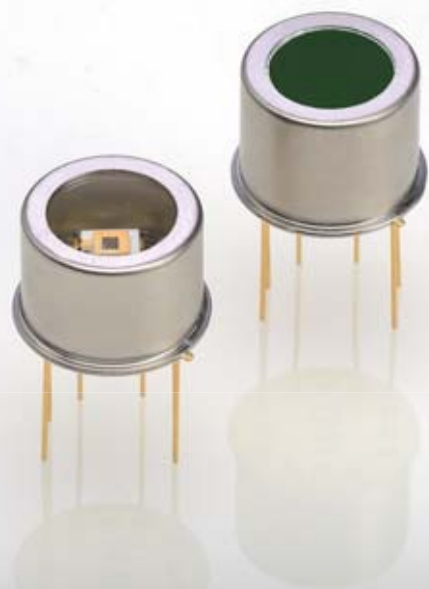


Infrared Detectors

Covering a broad spectral range in the infrared region



INFRARED DETECTORS

Infrared detectors

Infrared detectors are widely used in diverse field including measurement, analysis, industry, communication, agriculture, medicine, physical and chemical science, astronomy and space. Based on long experience involving photonic technology, Hamamatsu provides a wide variety of infrared detectors in order to meet a large range of application needs. In addition to the standard devices listed in this catalog, custom devices are also available on request. Please feel free to contact the nearest sales office in your area.



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■ InGaAs PIN photodiodes	1
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Infrared detectors

■ InAs/InAsSb/InSb photovoltaic detectors, InSb photoconductive detectors.....	10	■ Thermopile detectors (Si thermal detectors).....	13	■ Photon drag detector.....	16
		■ Two-color detectors.....	14	■ Accessories for infrared detectors	17
				■ Description of terms.....	23

Infrared detectors

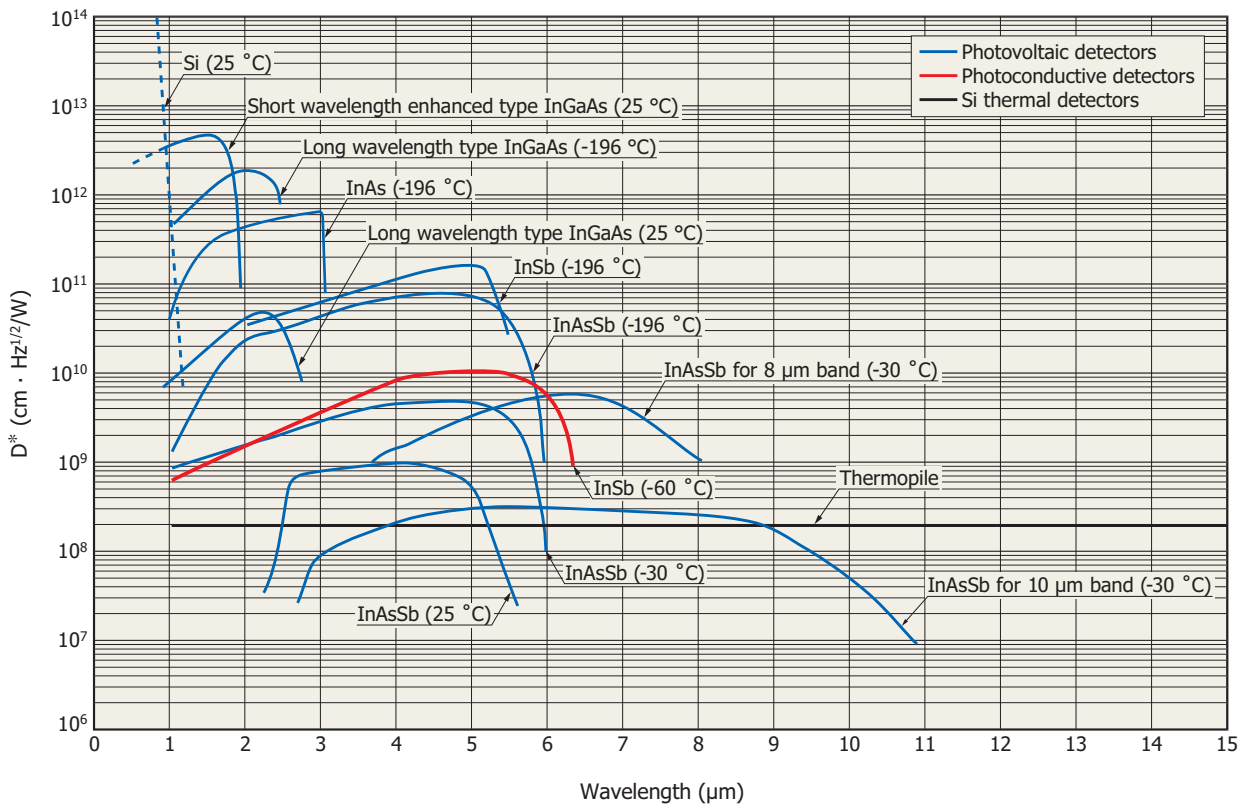
■ Hamamatsu infrared detectors

Product name	Spectral response range (μm)				Features	Page
	0	1	2	3		
InGaAs PIN photodiodes	0.5	1.7			<ul style="list-style-type: none"> • Short wavelength enhanced type • Can detect light from 0.5 μm 	1
	0.9	1.7			<ul style="list-style-type: none"> • Standard type • High-speed response, high sensitivity, low dark current • Available various types of photosensitive areas, arrays and packages 	1, 2, 6
	0.9	1.9			<ul style="list-style-type: none"> • For optical measurement around 1.7 μm • Available TE-cooled type 	3
	0.9	2.1			<ul style="list-style-type: none"> • For optical measurement in the band of water content absorption (1.9 μm) • Available TE-cooled type 	3
	0.9	2.6			<ul style="list-style-type: none"> • For NIR spectroscopy • Available TE-cooled type 	4
InGaAs image sensors	0.5	2.55			<ul style="list-style-type: none"> • Types for spectrophotometry and WDM monitor, and high-speed type available 	7 to 9

Product name	Spectral response range (μm)						Features	Page
	0	5	10	15	20	25		
InAs photovoltaic detectors	1	3.8					<ul style="list-style-type: none"> • Covers a spectral response range close to PbS but offers higher response speed 	10
InAsSb photovoltaic detectors	1	11					<ul style="list-style-type: none"> • Infrared detectors in the 5 μm, 8 μm, or 10 μm spectral band, with high sensitivity and high reliability • High-speed response 	10
InSb photovoltaic detectors	1	5.5					<ul style="list-style-type: none"> • High-speed and high sensitivity in so-called atmospheric window (3 to 5 μm) 	11
InSb photoconductive detectors	1	6.7					<ul style="list-style-type: none"> • Detects wavelengths up to around 6.5 μm, with high sensitivity over long periods by thermoelectric cooling 	12
Thermopile detectors	1	25					<ul style="list-style-type: none"> • Sensors that generate thermoelectromotive force in proportion to the energy level of incident infrared light 	13
Two-color detectors	Si + InAsSb	0.32	5.3				<ul style="list-style-type: none"> • Wide spectral response range from UV to IR • Uses two detectors with different spectral response ranges, mounted one over the other along the same optical axis 	14, 15
	Si + InGaAs	0.32	2.55					
	InGaAs + InGaAs	0.9	2.55					
Photon drag detector			10				<ul style="list-style-type: none"> • High-speed detector with high sensitivity in 10 μm band (for CO₂ laser detection) • Room temperature operation with high-speed response 	16

For detailed information on the products listed in this catalog, see their datasheets that are available from our website www.hamamatsu.com

Spectral response of Hamamatsu infrared detectors (typical example)



KIRDB0259EI

When using infrared detectors, the following points should be taken into consideration for making a device selection.

Spectral response

As can be seen from the figure above, Hamamatsu provides a variety of infrared detectors with different spectral response characteristics. It should be noted that cooling a detector element may affect its spectral response. For InGaAs, InAs, InSb and InAsSb detectors, the spectral response shifts to the shorter wavelength side.

Response speed

Various detectors are available with different response speeds.

Photosensitive area and number of elements

Hamamatsu photosensors are available in a wide range of photosensitive area sizes. Also available are multi-element detector arrays optimized for high-speed multichannel spectrophotometry.

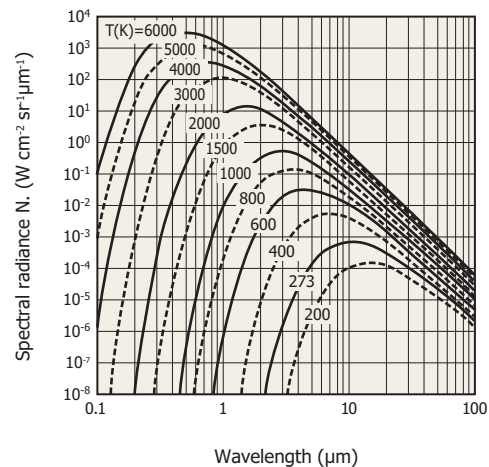
Cooling

Besides easy-to-use photosensors designed for room temperature, Hamamatsu provides various types of sensors that are cooled with thermoelectric coolers, cryogenic dewars (for liquid nitrogen cooling).

Object temperature

When selecting a detector in accordance with the temperature of an object, it is necessary to consider the distribution of the energy (the wavelength dependency of the energy) radiated from the object. When the temperature of the object is changed, the distribution of the radiating energy is given by the law of black body radiation (Planck's law), as shown in the figure at the right-hand side. The following relationship is established by the peak sensitivity wavelength λ_p (μm) and the absolute temperature T (K).
 $\lambda_p \cdot T = 2897.9$

Law of black body radiation (Planck's law)




KIRDB0014EB

InGaAs PIN photodiodes

Short wavelength enhanced type

(Typ. Ta=25 °C, unless otherwise noted)





Type no.	Cooling	Photosensitive area (mm)	Spectral response range λ (μm)	Peak sensitivity wavelength λ_p (μm)	Cutoff frequency f_c $V_R=1\text{ V}$ (MHz)	Package	Photo	Option (sold separately)
G10899-003K	Non-cooled	$\phi 0.3$	0.5 to 1.7	1.55	300	TO-18		C4159-03 (P.21)
G10899-005K		$\phi 0.5$			150			
G10899-01K		$\phi 1$			45			
G10899-02K		$\phi 2$			10	TO-5		
G10899-03K		$\phi 3$			5			

Standard type

Metal package

Various photosensitive area sizes are available.




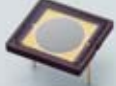
(Typ. Ta=25 °C, unless otherwise noted)

Type no.	Cooling	Photosensitive area (mm)	Spectral response range λ (μm)	Peak sensitivity wavelength λ_p (μm)	Cutoff frequency f_c (MHz)	Package	Photo	Option (sold separately)
G12180-003A	Non-cooled	$\phi 0.3$	0.9 to 1.7	1.55	600 ($V_R=5\text{ V}$)	TO-18		C4159-03 (P.21)
G12180-005A		$\phi 0.5$			200 ($V_R=5\text{ V}$)			
G12180-010A		$\phi 1$			60 ($V_R=5\text{ V}$)			
G12180-020A		$\phi 2$			13 ($V_R=1\text{ V}$)	TO-5		
G12180-030A		$\phi 3$			7 ($V_R=1\text{ V}$)			
G12180-050A		$\phi 5$			3 ($V_R=1\text{ V}$)	TO-8		
G8370-81*		$\phi 1$			35 ($V_R=1\text{ V}$)	TO-18		
G8370-82*		$\phi 2$			4 ($V_R=1\text{ V}$)	TO-5		
G8370-83*		$\phi 3$			2 ($V_R=1\text{ V}$)			
G8370-85*		$\phi 5$			0.6 ($V_R=1\text{ V}$)	TO-8		
G12180-110A	One-stage TE-cooled ($T_{\text{chip}}=-10\text{ }^\circ\text{C}$)	$\phi 1$	0.9 to 1.67		40 ($V_R=1\text{ V}$)	TO-8		C4159-03 (P.21) A3179 (P.19) C1103-04 (P.18)
G12180-120A		$\phi 2$			13 ($V_R=1\text{ V}$)			
G12180-130A		$\phi 3$			7 ($V_R=1\text{ V}$)			
G12180-150A		$\phi 5$			3 ($V_R=1\text{ V}$)			
G12180-210A	Two-stage TE-cooled ($T_{\text{chip}}=-20\text{ }^\circ\text{C}$)	$\phi 1$	0.9 to 1.65		40 ($V_R=1\text{ V}$)	TO-8		C4159-03 (P.21) A3179-01 (P.19) C1103-04 (P.18)
G12180-220A		$\phi 2$			13 ($V_R=1\text{ V}$)			
G12180-230A		$\phi 3$			7 ($V_R=1\text{ V}$)			
G12180-250A		$\phi 5$			3 ($V_R=1\text{ V}$)			
G6854-01	Non-cooled	$\phi 0.08$	0.9 to 1.7		2000 ($V_R=5\text{ V}$)	TO-18 with CD lens		

* Low PDL (polarization dependent loss) type






Ceramic package

(Typ. Ta=25 °C)

Type no.	Photosensitive area (mm)	Spectral response range λ (μm)	Peak sensitivity wavelength λ_p (μm)	Cutoff frequency f_c $V_R=5\text{ V}$ (MHz)	Package	Photo
G11193-02R	$\phi 0.2$	0.9 to 1.7	1.55	1000	Surface mount type ceramic	
G11193-03R	$\phi 0.3$			500		
NEW G11193-10R	$\phi 1$			60		
G8370-10	$\phi 10$			0.1 ($V_R=0\text{ V}$)	Ceramic	

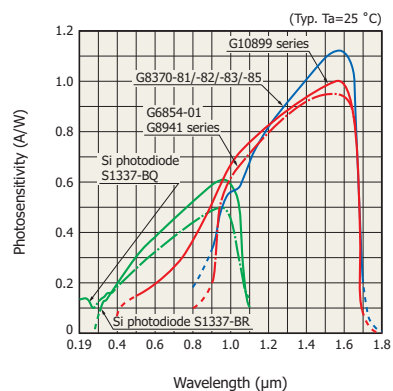
Surface mount type

(Typ. Ta=25 °C)

Type no.	Photosensitive area (mm)	Spectral response range λ (μm)	Peak sensitivity wavelength λ_p (μm)	Cutoff frequency f_c $V_R=5\text{ V}$ (MHz)	Package	Photo	Type
G8941-01	$\phi 1$	0.9 to 1.7	1.55	35	Ceramic (non-sealed)		Front-illuminated type
G8941-02	$\phi 0.5$			200			
G8941-03	$\phi 0.3$			400	Ceramic (non-sealed)		COB
NEW G13176-003P				600	Plastic		
NEW G13176-010P	$\phi 1$	60	Plastic				

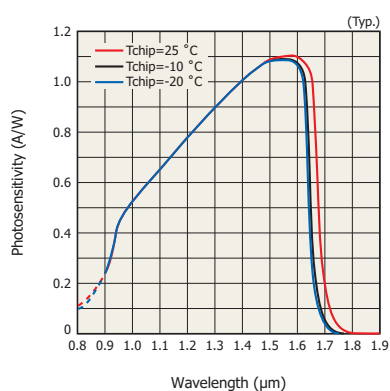
Spectral response

G10899 series, etc.



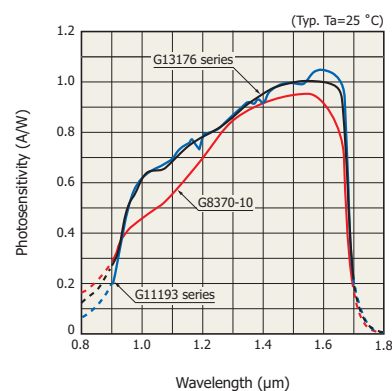
KIRDB0444EE

G12180 series



KIRDB0374EC

G11193/G13176 series, G8370-10





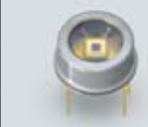
KIRDB0284ED

Long wavelength type

Peak sensitivity wavelength: 1.75 μm

These are suitable for optical measurement around 1.7 μm .



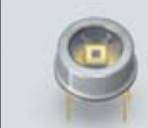
(Typ. $T_a=25\text{ }^\circ\text{C}$, unless otherwise noted)

Type no.	Cooling	Photosensitive area (mm)	Spectral response range λ (μm)	Peak sensitivity wavelength λ_p (μm)	Cutoff frequency f_c $V_R=0\text{ V}$ (MHz)	Package	Photo	Option (sold separately)
G12181-003K	Non-cooled	$\phi 0.3$	0.9 to 1.9	1.75	90	TO-18		C4159-03 (P.21)
G12181-005K		$\phi 0.5$			35			
G12181-010K		$\phi 1$			10			
G12181-020K		$\phi 2$			2.5	TO-5		
G12181-030K		$\phi 3$			1.5			
G12181-103K	One-stage TE-cooled ($T_{\text{chip}}=-10\text{ }^\circ\text{C}$)	$\phi 0.3$	0.9 to 1.87		140	TO-8		C4159-03 (P.21) A3179 (P.19) C1103-04 (P.18)
G12181-105K		$\phi 0.5$			50			
G12181-110K		$\phi 1$			16			
G12181-120K		$\phi 2$			3.5			
G12181-130K		$\phi 3$			1.8			
G12181-203K	Two-stage TE-cooled ($T_{\text{chip}}=-20\text{ }^\circ\text{C}$)	$\phi 0.3$	0.9 to 1.85		150	TO-8		C4159-03 (P.21) A3179-01 (P.19) C1103-04 (P.18)
G12181-205K		$\phi 0.5$			53			
G12181-210K		$\phi 1$			17			
G12181-220K		$\phi 2$			3.7			
G12181-230K		$\phi 3$			1.9			

Peak sensitivity wavelength: 1.95 μm

These are suitable for optical measurement in the 1.9 μm band such as water absorption.




(Typ. $T_a=25\text{ }^\circ\text{C}$, unless otherwise noted)

Type no.	Cooling	Photosensitive area (mm)	Spectral response range λ (μm)	Peak sensitivity wavelength λ_p (μm)	Cutoff frequency f_c $V_R=0\text{ V}$ (MHz)	Package	Photo	Option (sold separately)
G12182-003K	Non-cooled	$\phi 0.3$	0.9 to 2.1	1.95	90	TO-18		C4159-03 (P.21)
G12182-005K		$\phi 0.5$			35			
G12182-010K		$\phi 1$			10			
G12182-020K		$\phi 2$			2.5	TO-5		
G12182-030K		$\phi 3$			1.5			
G12182-103K	One-stage TE-cooled ($T_{\text{chip}}=-10\text{ }^\circ\text{C}$)	$\phi 0.3$	0.9 to 2.07		140	TO-8		C4159-03 (P.21) A3179 (P.19) C1103-04 (P.18)
G12182-105K		$\phi 0.5$			50			
G12182-110K		$\phi 1$			16			
G12182-120K		$\phi 2$			3.5			
G12182-130K		$\phi 3$			1.8			
G12182-203K	Two-stage TE-cooled ($T_{\text{chip}}=-20\text{ }^\circ\text{C}$)	$\phi 0.3$	0.9 to 2.05		150	TO-8		C4159-03 (P.21) A3179-01 (P.19) C1103-04 (P.18)
G12182-205K		$\phi 0.5$			53			
G12182-210K		$\phi 1$			17			
G12182-220K		$\phi 2$			3.7			
G12182-230K		$\phi 3$			1.9			

Peak sensitivity wavelength: 2.3 μm

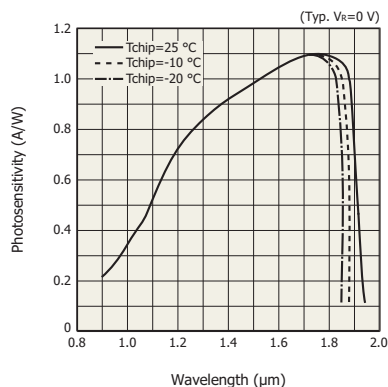
These are suitable for use in NIR (near infrared) spectroscopy.

(Typ. $T_a=25\text{ }^\circ\text{C}$, unless otherwise noted)

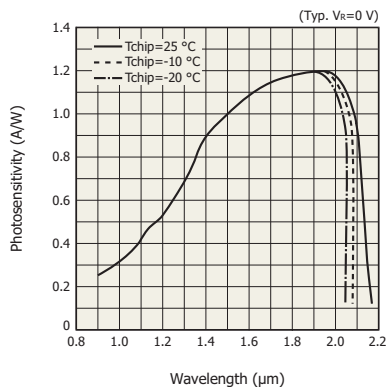
Type no.	Cooling	Photosensitive area (mm)	Spectral response range λ (μm)	Peak sensitivity wavelength λ_p (μm)	Cutoff frequency f_c $V_R=0\text{ V}$ (MHz)	Package	Photo	Option (sold separately)
G12183-003K	Non-cooled	$\phi 0.3$	0.9 to 2.6	2.3	50	TO-18		C4159-03 (P.21)
G12183-005K		$\phi 0.5$			20			
G12183-010K		$\phi 1$			6			
G12183-020K		$\phi 2$			1.5	TO-5		
G12183-030K		$\phi 3$			0.8			
G12183-103K	One-stage TE-cooled ($T_{\text{chip}}=-10\text{ }^\circ\text{C}$)	$\phi 0.3$	0.9 to 2.57	2.3	70	TO-8		C4159-03 (P.21) A3179 (P.19) C1103-04 (P.18)
G12183-105K		$\phi 0.5$			25			
G12183-110K		$\phi 1$			7			
G12183-120K		$\phi 2$			2			
G12183-130K		$\phi 3$			0.9			
G12183-203K	Two-stage TE-cooled ($T_{\text{chip}}=-20\text{ }^\circ\text{C}$)	$\phi 0.3$	0.9 to 2.55	2.3	75	TO-8		C4159-03 (P.21) A3179-01 (P.19) C1103-04 (P.18)
G12183-205K		$\phi 0.5$			28			
G12183-210K		$\phi 1$			8			
G12183-220K		$\phi 2$			2.3			
G12183-230K		$\phi 3$			1			

Spectral response

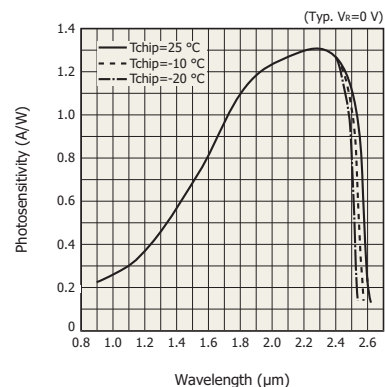
G12181 series



G12182 series






G12183 series



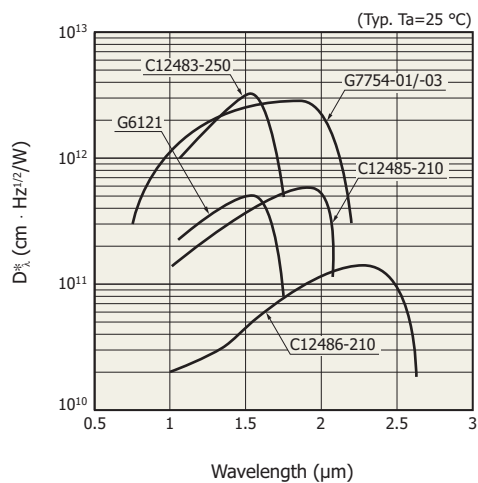
Infrared detector modules with preamp

These modules consist of the InGaAs PIN photodiode assembled with matched preamplifier, and operate by connecting a DC power supply. (Typ.)

Type no.	Detector	Cooling	Photosensitive area (mm)	Measurement condition	Cutoff wavelength λ_c (μm)	Peak sensitivity wavelength λ_p (μm)	Photo
				Chip temperature ($^{\circ}\text{C}$)			
G6121	G8370-05	Non-cooled	$\phi 5$	25	1.70	1.55	
C12483-250	G12180-250A	TE-cooled	$\phi 5$	-15	1.66	1.55	
C12485-210	G12182-210K		$\phi 1$		2.05	1.95	
C12486-210	G12183-210K		$\phi 1$		2.56	2.30	
G7754-01	G12183-010 (chip)	Liquid nitrogen	$\phi 1$	-196	2.4	2.0	
G7754-03	G12183-030 (chip)		$\phi 3$				

Note: Supplied with a power supply cable




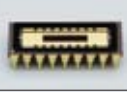



Spectral response



KIRDB0369EF

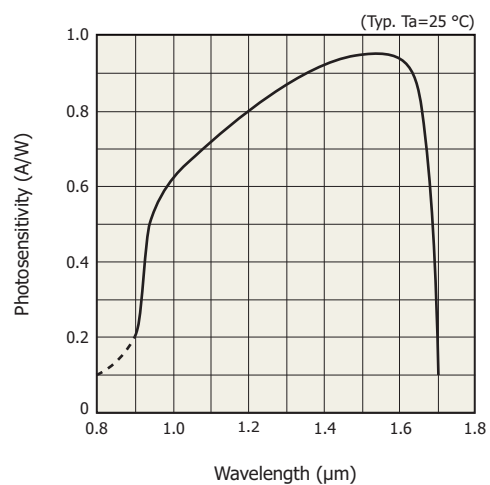
Hamamatsu also provides the C10439-10/-11 photodiode modules that integrate an InGaAs photodiode and a current-to-voltage conversion amplifier.

InGaAs photodiode arrays

Type no.	Photosensitive area (mm)	Spectral response range λ (μm)	Peak sensitivity wavelength λ_p (μm)	Package	Photo
G6849-01	$\phi 1$ (Quadrant element)	0.9 to 1.7	1.55	TO-5	
G6849	$\phi 2$ (Quadrant element)				
G7151-16	0.08×0.2 (16-element)			Ceramic	
G12430-016D	0.45×1.0 (16-element)				
G12430-032D	0.2×1.0 (32-element)				
G12430-046D	0.2×1.0 (46-element)				
G8909-01	$\phi 0.08$ (40-element)			Ceramic (Non-sealed)	

Spectral response







InGaAs photodiode arrays



KIRDB0002EB

InGaAs linear image sensors for spectrometry

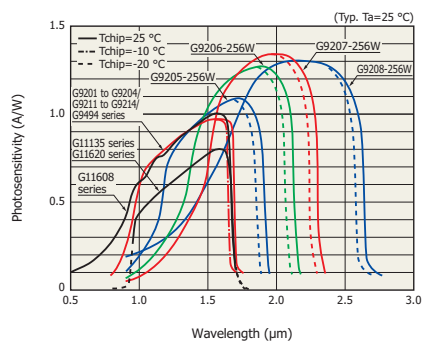
These linear image sensors are suitable for NIR (near infrared) spectrometers.

Type no.	Cooling	Pixel height (μm)	Pixel pitch (μm)	Number of pixels	Line rate (lines/s)	Spectral response range λ (μm)	Defective pixels	Photo	Dedicated driver circuit (sold separately)
G9203-256D	Non-cooled	500	50	256	1910	0.9 to 1.7	0		—
G9204-512D			25	512	960*				
G11608-256DA			50	256	17200	0.5 to 1.7	1% max.		
G11608-512DA			25	512	9150*				
G9211-256S	One-stage TE-cooled (Tchip=-10 °C)	250	50	256	1910	0.9 to 1.67	1% max.		C8061-01
G9212-512S			25	512	960*				
G9213-256S		500	50	256	1910				
G9214-512S			25	512	960*				
G9201-256S		250	50	256	1910	0			
G9202-512S			25	512	960*				
G9203-256S		500	50	256	1910	0			
G9204-512S			25	512	960*				
G9205-256W	Two-stage TE-cooled (Tchip=-20 °C)	250	50	256	1910	0.9 to 1.85	5% max.		C8062-01
G9206-256W						0.9 to 2.05			
G9206-02						0.9 to 2.15			
G9207-256W						0.9 to 2.25			
G9208-256W		0.9 to 2.55							
G9205-512W		25	512	960*	0.9 to 1.85	4% max.			
G9206-512W					0.9 to 2.15				
G9208-512W					0.9 to 2.55				

* When two video lines are used for readout, the line rate is equal to that for 256 channels.

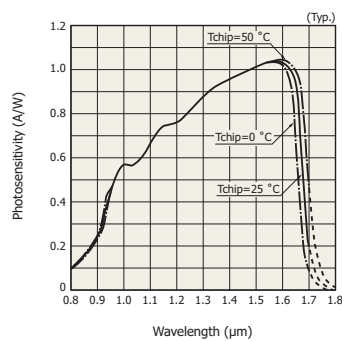
Spectral response

G9201 to G9208 series, etc.



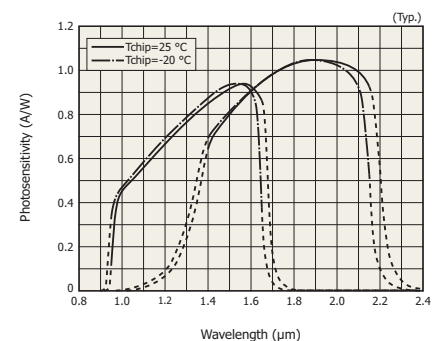
KMIRB0068EF

G10768 series



KMIRB0042EC



G12230-512WB



KMIRB0094EB


High-speed type InGaAs linear image sensors

These are linear image sensors with high-speed data rate designed for industrial measuring instruments.

Type no.	Cooling	Pixel height (μm)	Pixel pitch (μm)	Number of pixels	Line rate (lines/s)	Spectral response range λ (μm)	Defective pixels	Photo	Dedicated driver circuit (sold separately)
G9494-256D	Non-cooled	50	50	256	7100	0.9 to 1.7	1% max.		C10820
G9494-512D		25	25	512	3720*				


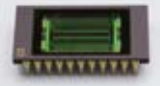






* When two video lines are used for readout, the line rate is equal to that for 256 channels.

The G10768 series is a high-speed infrared image sensor with 1024 pixels designed for applications such as foreign object screening and medical diagnostic equipment where a multichannel high-speed line rate is required.

Type no.	Cooling	Pixel height (μm)	Pixel pitch (μm)	Number of pixels	Line rate (lines/s)	Spectral response range λ (μm)	Defective pixels	Photo	Dedicated driver circuit (sold separately)
G10768-1024D	Non-cooled	100	25	1024	39000	0.9 to 1.7	1% max.		C10854
G10768-1024DB		25							


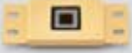





Back-illuminated type InGaAs linear image sensors

The back-illuminated InGaAs photodiode and CMOS-ROIC are bump bonded to provide a single output terminal.

Type no.	Cooling	Pixel height (μm)	Pixel pitch (μm)	Number of pixels	Line rate (lines/s)	Spectral response range λ (μm)	Defective pixels	Photo	Dedicated driver circuit (sold separately)		
G11135-256DD	Non-cooled	50	50	256	14000	0.95 to 1.7	1% max.		C11514		
G11135-512DE		25	25	512	8150						
G11620-128DA		500	50	25	128			30800		C11513	
G11620-256DA					256			17200			
G11620-256DF				25	256			17200			
G11620-512DA					512			9150			
G11620-256SA	One-stage TE-cooled (Tchip=-10 °C)	500	50	256	17200	0.95 to 1.67		—			
G11620-512SA			25	512	9150						
 G12230-512WB	Two-stage TE-cooled (Tchip=-20 °C)	250	25	254 + 254	9150	0.95 to 2.15	2% max.		—		

InGaAs area image sensors

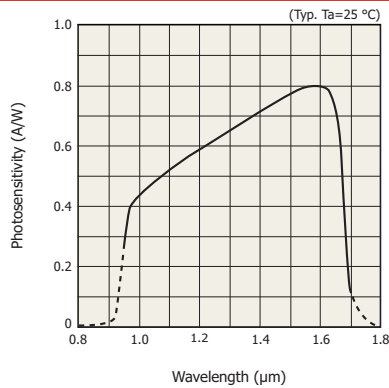
The InGaAs area image sensors have a hybrid structure consisting of a CMOS readout circuit (ROIC: readout integrated circuit) and back-illuminated InGaAs photodiodes.

Type no.	Cooling	Pixel height (μm)	Pixel pitch (μm)	Number of pixels	Frame rate* (frames/s)	Spectral response range λ (μm)	Defective pixels	Photo	Dedicated driver circuit (sold separately)
G11097-0606S	One-stage TE-cooled (Tchip=25 °C)	50	50	64 × 64	1025	0.95 to 1.7	1% max.		C11512
G11097-0707S				128 × 128	279				C11512-01
G12460-0606S	One-stage TE-cooled (Tchip=0 °C)	20	20	64 × 64	1025	1.12 to 1.9	1% max.		C11512
G12242-0707W	Two-stage TE-cooled (Tchip=15 °C)			128 × 128	258	0.95 to 1.7		0.37% max.	
NEW G13393-0808W		320 × 256	228		—				
NEW G13393-0909W		640 × 512	62						
NEW G13441-01	Two-stage TE-cooled (Tchip=-20 °C)	50	50	192 × 96	867	1.3 to 2.15	1% max.		

* Integration time 1 μs (min.)

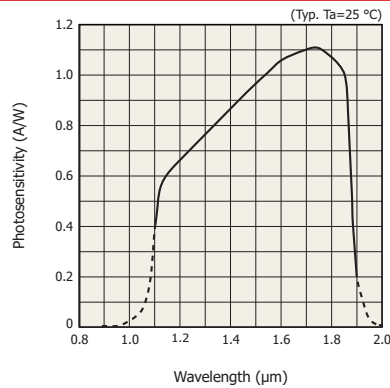
Spectral response

G11097 series, G12242-0707W



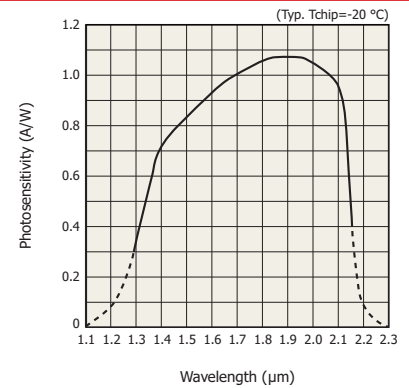
KMIRB0051EB

G12460-0606S



KMIRB0078EA

G13441-01






KMIRB0099EB

InAs/InAsSb/InSb photovoltaic detectors, InSb photoconductive detectors

InAs photovoltaic detectors are capable of detecting infrared light up to approx. 3.5 μm . InSb photovoltaic detector can sense infrared light up to approx. 5.5 μm , and InSb photoconductive detectors infrared light up to approx. 6 μm . InAsSb photovoltaic detectors also delivers high sensitivity in the 5 μm , 8 μm , or 10 μm band. InSb photoconductive detectors are available in multi-element arrays (custom-made product). InAs and InSb photovoltaic detectors cover a spectral response range equivalent to PbS and PbSe photoconductive detectors, respectively, and feature higher response speed and better S/N.








InAs photovoltaic detectors

InAs photovoltaic detectors are high-speed, low-noise infrared detectors capable of detecting infrared light up to approx. 3.5 μm . (Typ.)

Type no.	Cooling	Photosensitive area (mm)	Cutoff wavelength λ_c (μm)	Peak sensitivity wavelength (μm)	Package	Photo	Option (sold separately)
P10090-01	Non-cooled	$\phi 1$	3.65	3.35	TO-5		C4159-07 (P.21)
P10090-11	One-stage TE-cooled (Tchip=-10 °C)		3.55	3.30	TO-8		A3179-01 (P.19) C1103-04 (P.18) C4159-06 (P.21)
P10090-21	Two-stage TE-cooled (Tchip=-30 °C)		3.45	3.25			A3179-01 (P.19) C1103-04 (P.18) C4159-06 (P.21)
P7163	Liquid nitrogen (Tchip=-196 °C)		3.10	3.00	Metal dewar		C4159-05 (P.21)


InAsSb photovoltaic detectors

InAsSb photovoltaic detectors have high infrared sensitivity with a cutoff wavelength in the 5 μm , 8 μm or 10 μm band. A small surface-mount package type (P13243-012CA) is also provided. (Typ.)

Type no.	Cooling	Photosensitive area (mm)	Cutoff wavelength λ_c (μm)	Peak sensitivity wavelength (μm)	Package	Photo	Option (sold separately)
P11120-901	Liquid nitrogen (Tchip=-196 °C)	$\phi 1$	5.8	4.8	Metal dewar		C4159-01 (P.21)
P11120-201	Two-stage TE-cooled (Tchip=-30 °C)		5.9	4.9	TO-8		A3179-01 (P.19) C1103-04 (P.18) C4159-07 (P.21)
NEW P13243-012CA	Non-cooled	0.7 × 0.7	5.3	3.5	Cramic		C4159-01 (P.21)
NEW P13243-011MA					TO-46		
P12691-201	Two-stage TE-cooled (Tchip=-30 °C)	$\phi 1$	8.3	6.7	TO-8		A3179-01 (P.19) C1103-04 (P.18) C4159-07 (P.21)
NEW P13894-011MA	Non-cooled	1 × 1	11.0	5.6	TO-5		C4159-01 (P.21)
NEW P13894-211MA	Two-stage TE-cooled (Tchip=-30 °C)		10.2		TO-8		A3179-01 (P.19) C1103-04 (P.18) C4159-01 (P.21)

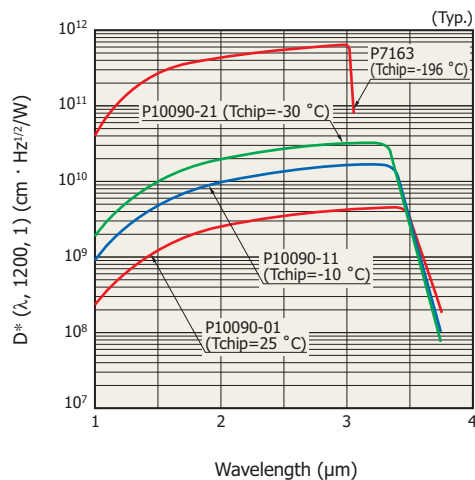
InSb photovoltaic detectors

InSb photovoltaic detectors are high-speed, low-noise infrared detectors that deliver high sensitivity in the so-called atmospheric window between 3 and 5 μm . The infrared light in the 5 μm band can be detected with peak sensitivity and high response speed. A metal dewar type cooled with liquid nitrogen is also available. (Typ.)

Type no.	Cooling	Photosensitive area (mm)	Cutoff wavelength λ_c (μm)	Peak sensitivity wavelength λ_p (μm)	Package	Photo	Option (sold separately)
P5968-060	Liquid nitrogen (Tchip=-196 °C)	$\phi 0.6$	5.5	5.3	Metal dewar		C4159-01 (P.21)
P5968-100		$\phi 1$					C4159-04 (P.21)
P5968-200		$\phi 2$					Custom-made product
P5968-300		$\phi 3$					—
P4247-16		0.25×1.4 (16-element)				—	
P4247-44		0.45×0.45 (4 x 4-element)				—	

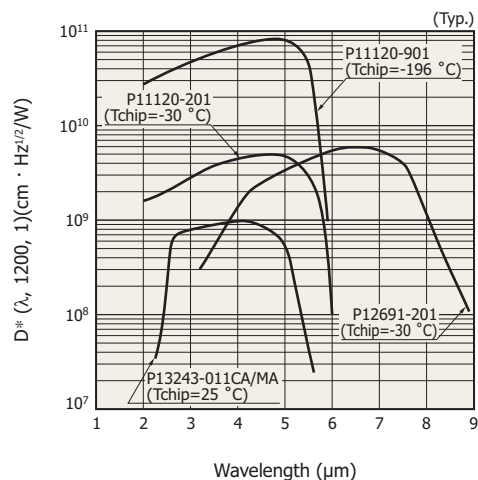
Spectral response

InAs photovoltaic detectors



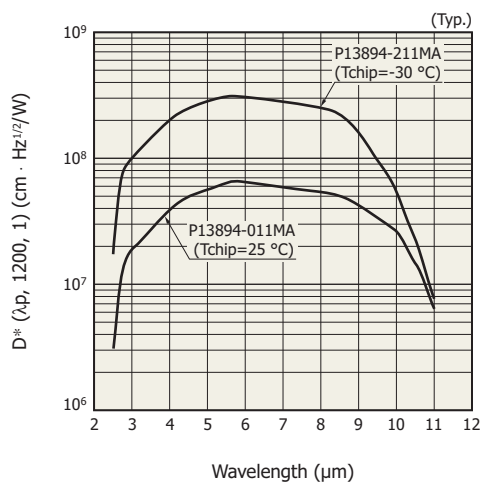
KIRD80356EE

P11120/P13243 series, P12691-201



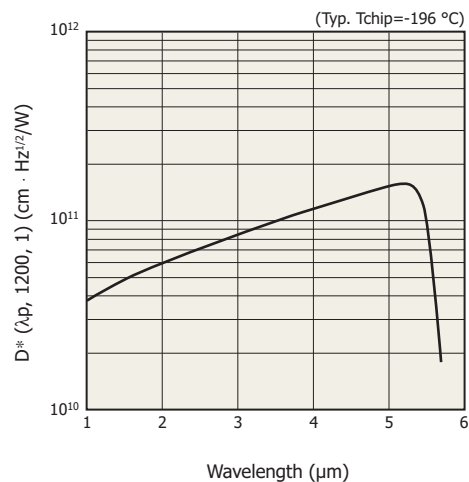
KIRD80430EH

P13894 series



KIRD80626EA



InSb photovoltaic detectors



KIRD80063EF




InSb photoconductive detectors

Thermoelectrically cooled InSb photoconductive detectors are capable of detecting infrared light up to around 6 μm with high sensitivity and high speed. (Typ.)

Type no.	Cooling	Photosensitive area (mm)	Cutoff wavelength λ_c (μm)	Peak sensitivity wavelength λ_p (μm)	Package	Photo	Option (sold separately)
P6606-110	One-stage TE-cooled (Tchip=-10 °C)	1 × 1	6.7	5.5	TO-8		A3179-01 (P.19) C1103-07 (P.18) C5185-02 (P.22)
P6606-210	Two-stage TE-cooled (Tchip=-30 °C)		6.5				
P6606-310	Three-stage TE-cooled (Tchip=-60 °C)	1 × 1	6.3		TO-3		A3179-04 (P.19) C1103-05 (P.18) C5185-02 (P.22)
P6606-305		0.5 × 0.5					
P6606-320		2 × 2					

Infrared detector modules with preamp

These modules consist of the InSb detector assembled with the matched preamplifier, and operate by connecting a DC power supply. (Typ.)

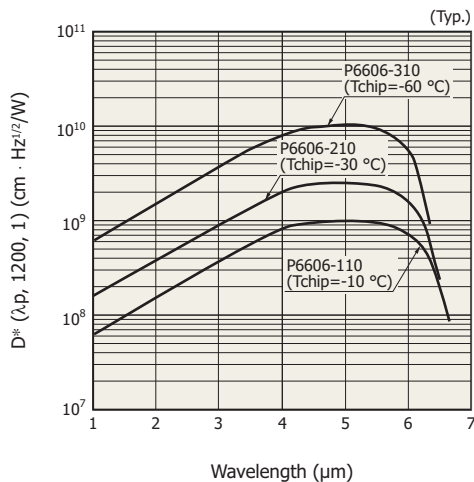
Type no.	Detector	Photosensitive area (mm)	Cooling	Measurement condition	Cutoff wavelength λ_c (μm)	Peak sensitivity wavelength λ_p (μm)	Photo
				Chip temperature (°C)			
P4631-03	InSb (P6606-310)	1 × 1	TE-cooled	-58	6.1	5.5	
P7751-01*	InSb (P5968-060)	ϕ 0.6	Liquid nitrogen	-196	5.5	5.3	
P7751-02*	InSb (P5968-200)	ϕ 2					
C12492-210	InAs (P10090-21)	ϕ 1	TE-cooled	-28	3.45	3.25	
C12494-210S	InAsSb (P11120-201)				5.9	4.9	
C12494-210M	InAsSb (P12691-201)				8.3	6.7	

* FOV=60°

Note: Supplied with a power supply cable

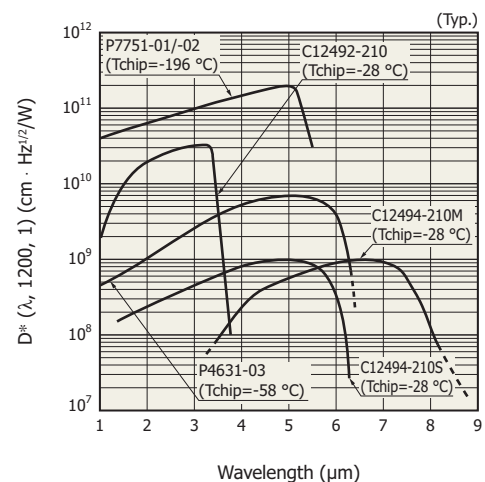
Spectral response

InSb photoconductive detectors



KIRD80166ED

Infrared detector module with preamp



KIRD80371EH


Hamamatsu also provides the C10439-14 photodiode module that integrates an InAsSb photovoltaic detector and a current-to-voltage conversion amplifier.

Thermopile detectors (Si thermal detectors)

Single-element type

Hamamatsu provides high-sensitivity thermopile detectors suitable for gas concentration measurement, etc. Concentration of various types of gases can be measured by attaching a band-pass filter to thermopile detectors.


The T11262-06 is suitable for flame detection and the T11361-05 for CO₂ concentration measurement.

Type no.	Package	Number of elements	Photosensitive area (mm)	Window	Spectral response (μm)	Photo
T11262-01	TO-18	1	1.2 × 1.2	AR-coated Si	3 to 5	
T11361-01*						
T11262-06				Band-pass filter	4.45	
T11361-05*					4.3	

* Built-in thermistor

Dual-element type

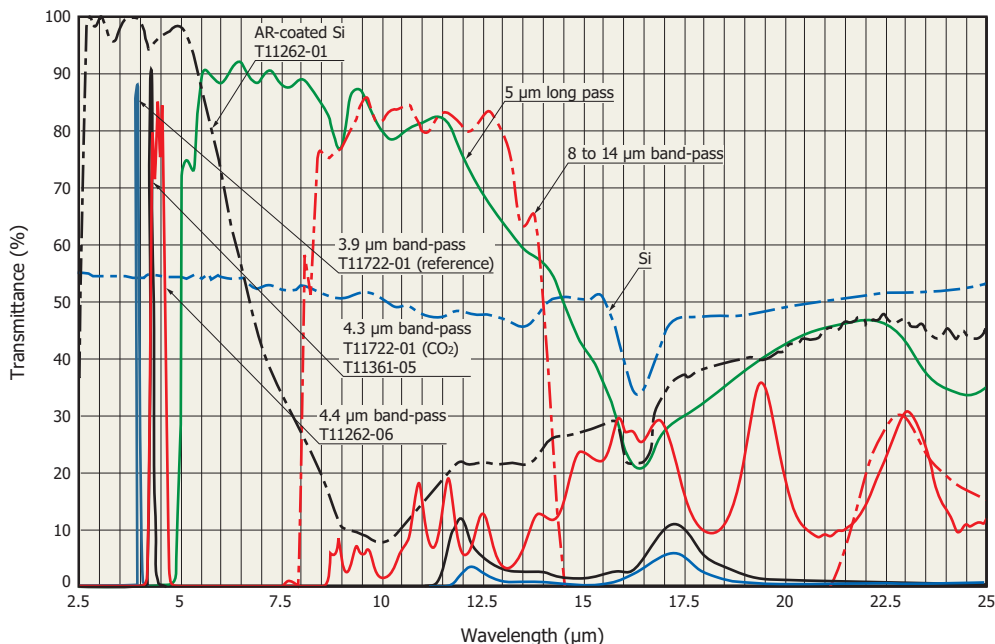
The T11722-01 is a dual-element type thermopile detector designed to detect CO₂ concentrations with a high accuracy. It consists of a high sensitivity dual-element thermopile detector and two band-pass filters for sensing two wavelengths (reference: 3.9 μm, CO₂: 4.3 μm) simultaneously.

Type no.	Package	Number of elements	Photosensitive area (mm)	Window	Spectral response (μm)	Photo
T11722-01	TO-5	2	1.2 × 1.2 (per 1 element)	Band-pass filter	Reference: 3.9 CO ₂ : 4.3	

Window options (typical examples of spectral response)

Since thermopile detectors have no wavelength dependence, their spectral response characteristics are determined only by the transmittance of the window material.

The graph below shows transmittance characteristics of typical window materials. Please contact our sales office about changing the window of a thermopile detector to the following materials.













KIRD0512EB

Two-color detectors

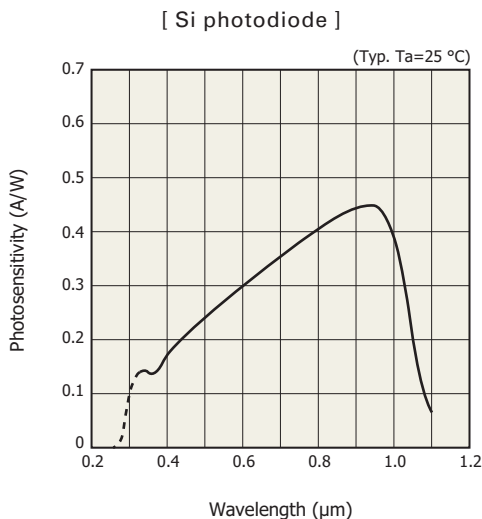
Two-color detectors use a combination of two light sensors with different spectral response, in which one sensor is mounted over the other sensor along the same optical axis to provide a broad spectral response range. Thermoelectrically cooled two-color detectors are also provided that cool the sensors to maintain their temperatures constant, allowing high precision measurement with an improved S/N.

(Typ.)

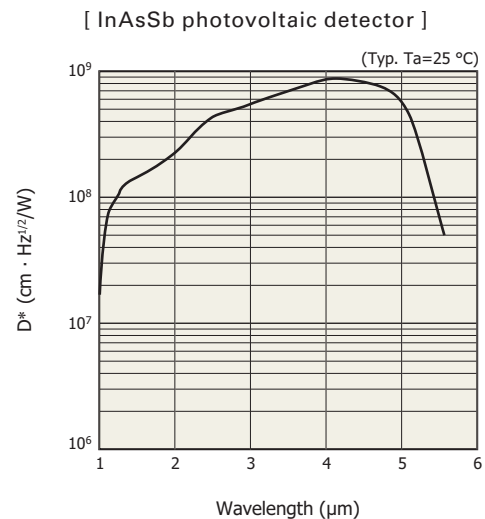
Type no.	Cooling	Detector	Photosensitive area (mm)	Spectral response range λ (μm)	Peak sensitivity wavelength λ_p (μm)	Photo-sensitivity S (A/W)	Package	Photo	Option (sold separately)										
NEW K1713-003	Non-cooled	Si	2.4 × 2.4	0.32 to 5.3	0.94	0.45	TO-5		C9329 C4159-01 (P.22)										
		InAsSb	0.7 × 0.7		3.5	0.0039													
K1713-05		Si	2.4 × 2.4	0.32 to 1.7	0.94	0.45			TO-8		C9329 C4159-03 (P.21)								
		InGaAs	$\phi 0.5$		1.55	0.55													
K1713-08		Si	2.4 × 2.4	0.32 to 2.6	0.94	0.45					Ceramic		C9329 C4159-03 (P.21)						
		InGaAs	$\phi 1$		2.3	0.60													
K1713-09		Si	2.4 × 2.4	0.32 to 1.7	0.94	0.45							Ceramic		C9329 C4159-03 (P.21)				
		InGaAs	$\phi 1$		1.55	0.55													
K11908-010K		InGaAs	2.4 × 2.4	0.9 to 2.55	1.55	0.95									Ceramic		C4159-03 (P.21)		
		InGaAs	$\phi 1$		2.1	1.0													
K3413-05	One-stage TE-cooled (Tchip=-10 °C)	Si	2.4 × 2.4	0.32 to 1.67	0.94	0.45	TO-8										C9329 C4159-03 (P.21)		
		InGaAs	$\phi 0.5$		1.55	0.55													
K3413-08		Si	2.4 × 2.4	0.32 to 2.57	0.94	0.45			TO-8								C9329 C4159-03 (P.21)		
		InGaAs	$\phi 1$		2.3	0.60													
K3413-09		Si	2.4 × 2.4	0.32 to 1.67	0.94	0.45					TO-8						A3179-03 (P.19) C1103-04 (P.18)		
		InGaAs	$\phi 1$		1.55	0.55													
K12728-010K		Non-cooled	Si	2.4 × 2.4	0.32 to 1.65	0.96							0.45	Ceramic				C9329 C4159-03 (P.21)	
			InGaAs	$\phi 1$		1.55							0.55						
K12729-010K			InGaAs	2.4 × 2.4	0.9 to 2.55	1.55							0.95		Ceramic				C9329 C4159-03 (P.21)
			InGaAs	$\phi 1$		2.1							1.0						

Spectral response

K1713-003

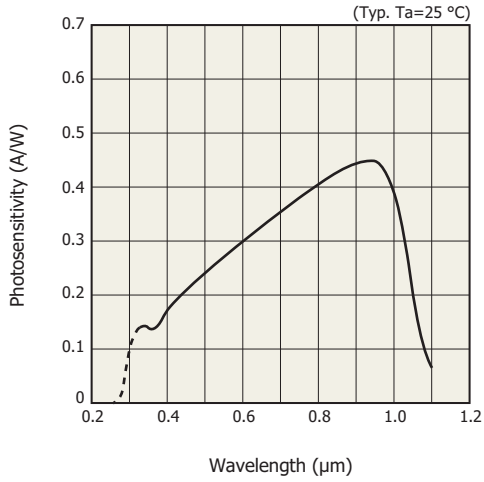


KIRD80199EA



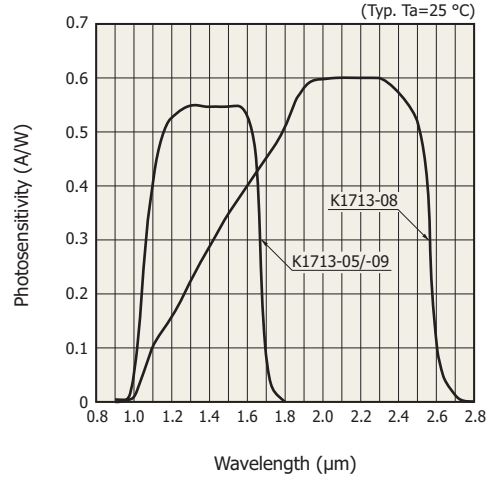
KIRD80623EA

[Si photodiode]



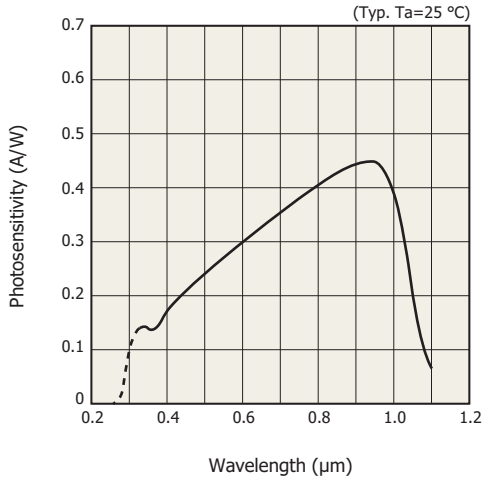
KIRD80199EA

[InGaAs PIN photodiode]



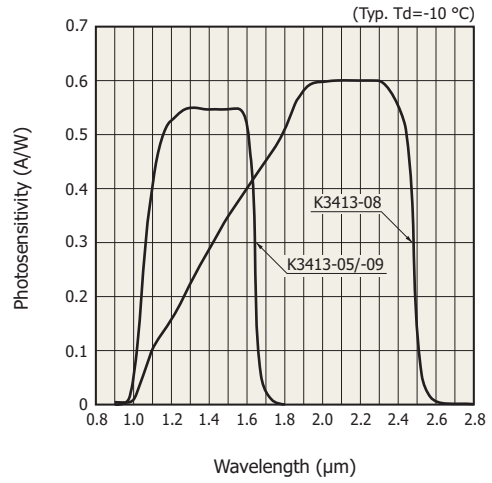
KIRD80211EA

[Si photodiode]

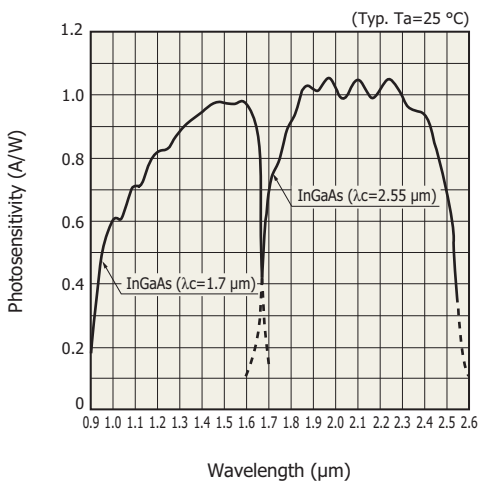


KIRD80199EA

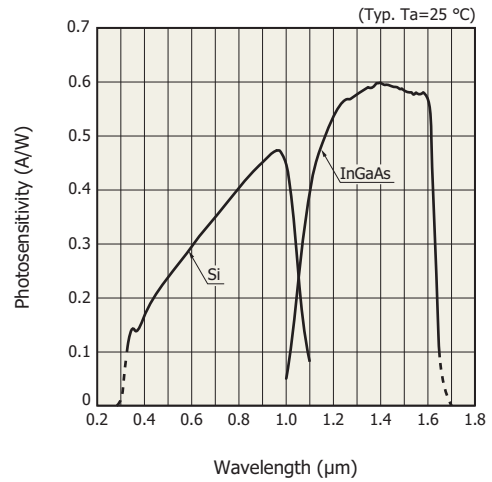
[InGaAs PIN photodiode]



KIRD80212EA



KIRD80479EB





KIRD80598EB

Photon drag detector

The photon drag detector makes use of the “photon drag effect” in which holes created in a semiconductor by incident photons are dragged along in the direction of the photons, generating an electromotive force. Because of its sensitivity at 10.6 μm, this detector is suitable for detection of CO₂ lasers. The surface of the detector element is coated with a non-reflective material. The C12496-046 is a infrared detector module with preamp designed to detect infrared light by connecting to a DC power supply.

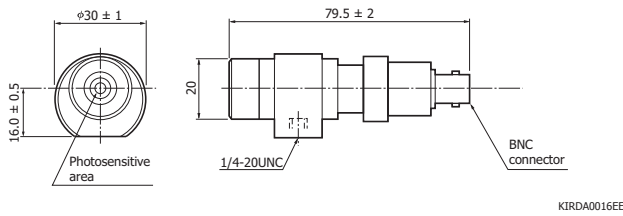
Non-cooled type

(Typ.)

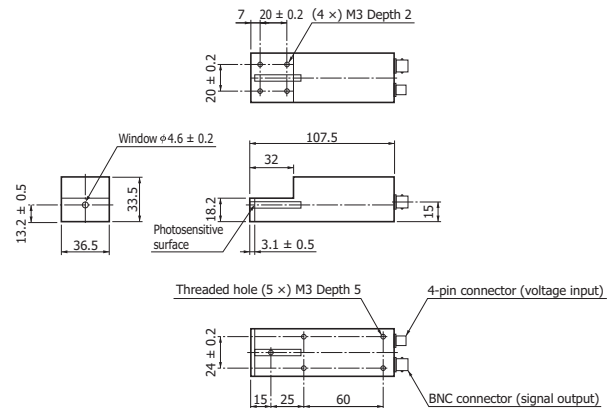
Type no.	Cooling	Photosensitive area (mm)	Peak sensitivity wavelength λ _p (μm)	Photosensitivity S λ=10.6 μm (V/W)	Photo	Magnet stand (sold separately)
B749	Non-cooled	φ5.0	10.6	1.2 × 10 ⁻⁶		A1447
C12496-046		φ4.6		1.3 × 10 ⁻²		-

Dimensional outlines (unit: mm, tolerance unless otherwise noted: ±1)

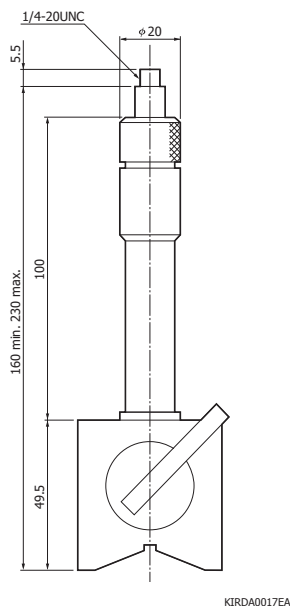
B749



C12496-046



Magnet stand A1447



Pin no.	Pin connection	Lead color
①	Vcc=+15 V	White
②	GND	Blue/white stranded wire
③	GND	Blue/white stranded wire
④	Vcc=-15 V	Blue

Tolerance unless otherwise noted: ±1

KIRDA0231EA

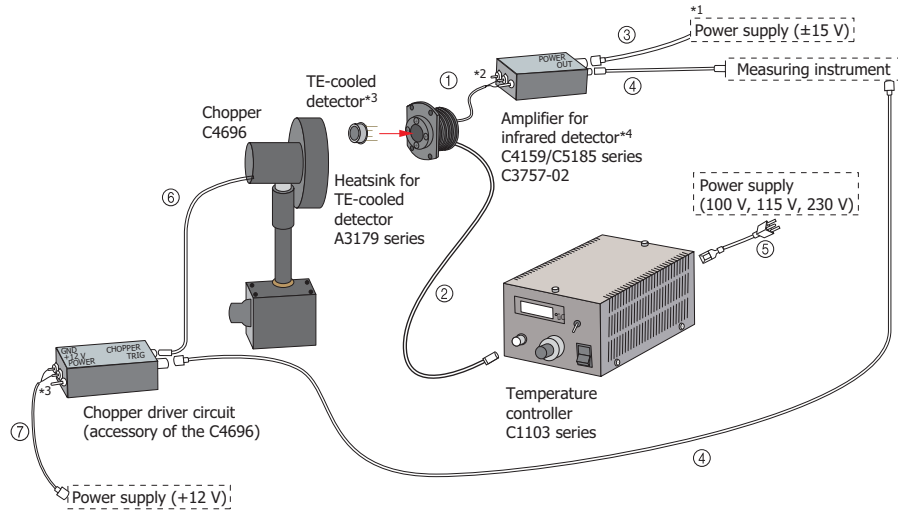
Accessories for infrared detectors

Hamamatsu provides following accessories for infrared detectors.

- Temperature controllers (P.18)
- Heatsinks for TE-cooled detector (P.19)
- Chopper (P.20)
- Amplifiers for infrared detectors (P.21)

A connection example is shown below.

Connection example



KACCC0321ED

Cable no.	Cable	Length approx.	Note
①	Coaxial cable (for signal)	2 m	Supplied with heatsink A3179 series. When using this cable, make it as short as possible (preferably approx. 10 cm).
②	4-conductor cable (with a connector) A4372-05	3 m	Supplied with temperature controller C1103 series. This cable is also sold separately.
③	Power supply cable (with a 4-conductor connector) A4372-02	2 m	This cable is supplied with the C4159 series, C5185-02 amplifiers for infrared detectors, and infrared detector modules with preamps (room temperature type). This cable is also sold separately. Besides this cable, the A4372-03, which is a power supply cable (with a 6-conductor connector) supplied with "infrared detector modules with preamps (TE-cooled type)", is also sold separately.
④	BNC connector cable E2573	1 m	Option
⑤	Power supply cable (for temperature controller)	1.9 m	Supplied with temperature controller C1103 series
⑥	Chopper driver cable (connected to chopper)	2 m	Connected to chopper driver circuit
⑦	2-conductor cable or coaxial cable (for chopper power supply)	2 m or less	Prepared by user

*1: Attach the bare wire ends to a 3-pin or 4-pin connector or to a banana jack, and then connect them to the power supply.

*2: Soldering is needed. When using the C5185-02 amplifier, a BNC connector (prepared by the user, example: one end of the E2573) is required.

*3: No socket is available. Soldering is needed.

Note: Refer to the datasheet "Accessories for infrared detectors" for detailed information about cables.

Temperature controllers C1103 series

The C1103 series is a temperature controller designed for TE-cooled infrared detectors. The C1103 series allows temperature setting for the TE-cooler mounted in an infrared detector.

Specifications

Parameter	C1103-04	C1103-05	C1103-07
Applicable detector*4	One-stage/two-stage TE-cooled type InAsSb, InAs photovoltaic detectors, InGaAs, Si photodiodes	Two-stage/three-stage TE-cooled type InSb photoconductive detectors	One-stage TE-cooled type InSb photoconductive detectors
Setting element temperature	-30 to +20 °C	-75 to -25 °C	-30 to +20 °C
Temperature stability	Within ±0.1 °C		
Temperature control output current	1.1 A min., 1.2 A typ., 1.3 A max.		
Power supply	100 V ± 10% · 50/60 Hz*5		
Power consumption	30 W		
Dimensions	107 (W) × 87 (H) × 190 (D) mm		
Weight	Approx. 1.9 kg		
Operating temperature	+10 to +40 °C		
Operating humidity	90% max.		
Storage temperature*6	-20 to +40 °C		
Accessories	Instruction manual 4-conductor cable (with a connector, 3 m) A4372-05*7, power supply cable		

*4: It does not correspond to TE-cooled type infrared detector module with preamp.

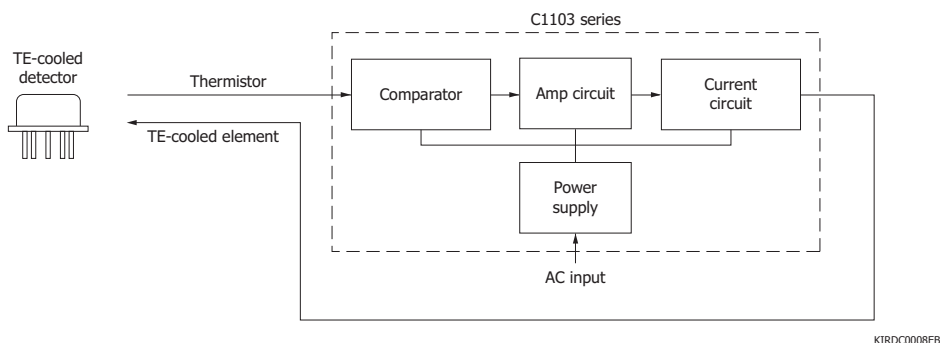
*5: Please specify power supply requirement (AC line voltage) from among 100 V, 115 V and 230 V when ordering.

*6: No dew condensation

When there is a temperature difference between a product and the surrounding area in high humidity environment, dew condensation may occur on the product surface. Dew condensation on the product may cause deterioration in characteristics and reliability.

*7: When used in combination with the A3179 series heatsink, do not use the 4-conductor cable supplied with the A3179 series, but use the A4372-05 instead.

Block diagram

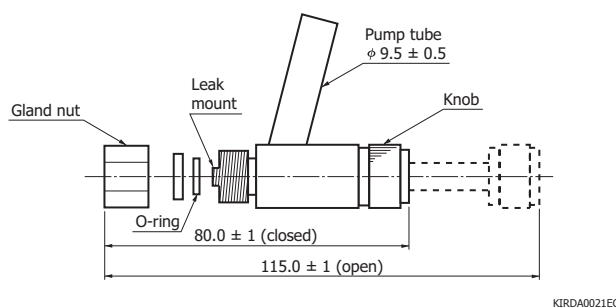


Valve operator for metal dewar A3515

With this valve operator, metal dewars can be re-evacuated to maintain the desired vacuum level. Refer to the instruction manual for details. Please be aware that the detector performance is not guaranteed after re-evacuation is performed with the valve operator.



Dimensional outline (unit: mm)



Heatsinks for TE-cooled detectors (TO-8, TO-3 package) A3179 series

These heatsinks are designed for use with thermoelectrically cooled detector sealed in a 6-pin TO-8, TO-3 package. The cooling (heat dissipation) capacity of the A3179 and A3179-03 is approx. 35 °C relative to the ambient temperature 25 °C, the A3179-01 is approx. 40 °C, and that of the A3179-04 is approx. 85 °C. The A3179-03 is designed only for two-color detector K3413 series, the A3179 for one-stage TE-cooled TO-8, the A3179-01 for two-stage TE-cooled TO-8, the A3179-04 for TO-3 (heatsink for TO-66 is available as a custom product.).

Accessories

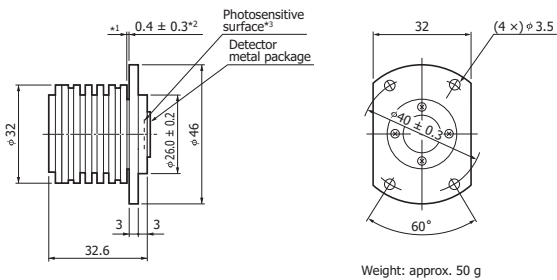
- Instruction manual
- 4-conductor cable (2 m): for TE-cooler and thermistor*1 *2
- Coaxial cable (2 m): for signal*2

*1: When used in combination with the C1103 series temperature controller, do not use the 4-conductor cable supplied with the A3179 series, but use the 4-conductor cable A4372-05 (sold separately, with a connector) that comes with the C1103 series.

*2: No socket is supplied for connection to infrared detectors. Connect infrared detectors by soldering. Cover the soldered joints and detector pins with vinyl insulating tubes.

Dimensional outlines (unit: mm, tolerance unless otherwise noted: ±0.3)

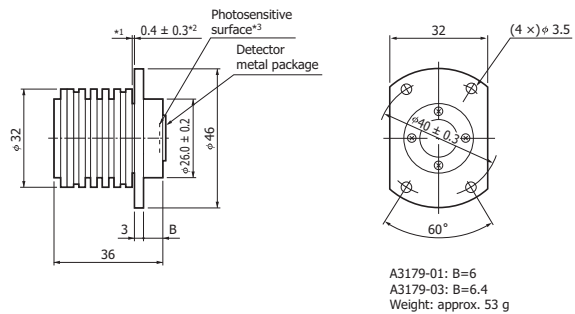
A3179



- *1: Bottom surface (reference surface) of detector metal package
- *2: When the detector is installed
- *3: The position of the photosensitive surface differs according to the detector used. Refer to the dimensional outline for the detector.

KIRDA0018EE

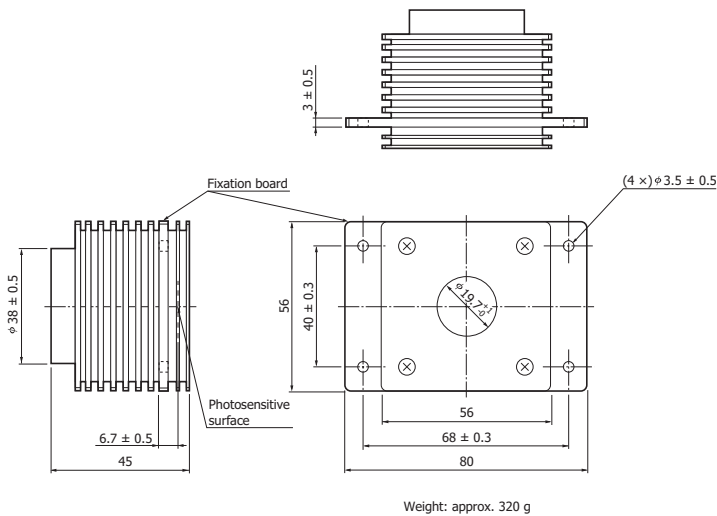
A3179-01, A3179-03



- *1: Bottom surface (reference surface) of detector metal package
- *2: When the detector is installed
- *3: The position of the photosensitive surface differs according to the detector used. Refer to the dimensional outline for the detector.

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A3179-04



KIRDA0149EC

Chopper C4696

Specifications

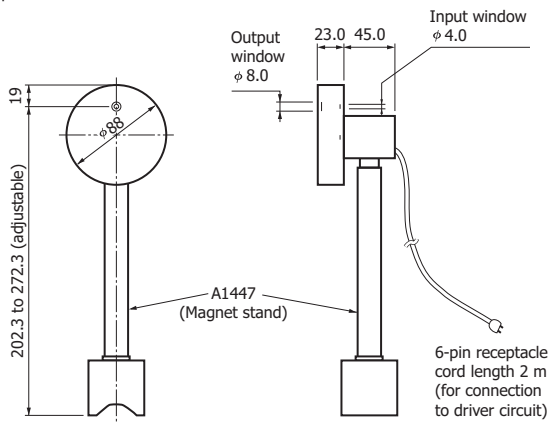
Parameter	Specification	
Chopping frequency	115 to 380 Hz, 345 Hz typ.*3	
Operating voltage V_D	DC 5 to 13 V, 12 V typ.	
Duty ratio	1:1	
Rotational stability	0.06%/°C	
Sync signal V_H (high level)	Min.	$V_D - 0.5 V$
	Max.	$V_D - 0.2 V$
Operating temperature	0 to 50 °C	
Maximum current consumption*4	90 mA	
Accessories	Magnet stand A1447 (see P.16), driver circuit	

*3: Chopping frequency will be 230 to 760 Hz when an optional disk is used.

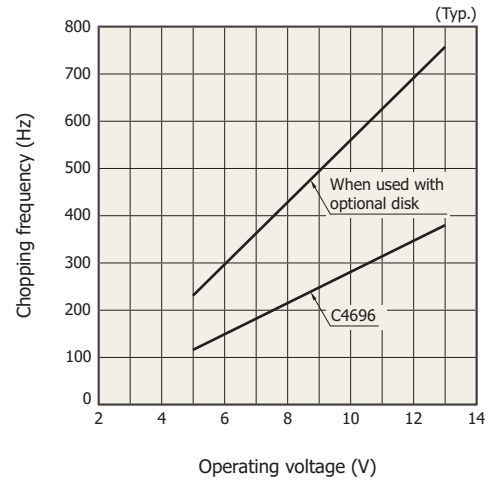
*4: $V_D=12 V$

Dimensional outline (unit: mm, tolerance unless otherwise noted: ±1)

<Chopper>

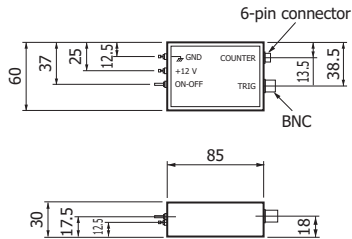


Chopping frequency vs. operating voltage



KIRDB0376EA

<Driver circuit>



KIRDA0022EA

Amplifiers for infrared detectors C4159 series, C5158-02

These are low noise amplifiers for InSb, InAs, InAsSb, and InGaAs detectors

Accessories

- Instruction manual
- Power cable (one end with 4-pin connector for connection to amplifier and the other end unterminated, 2 m) A4372-02



Required power supply specifications

- C4159 series: $\pm 15\text{ V} \pm 0.5$
- C5185-02: $\pm 15\text{ V} \pm 0.5$
- Current capacity: 1.5 times or more of amplifier's maximum current consumption
- Ripple noise: 5 mVp-p or less
- Analog power supply only
- Recommended DC power supply (example): PW18-3AD (TEXIO)
E3620A, E3630A (Agilent Technologies)

Absolute maximum ratings (Ta=25 °C)

Parameter	Value	Unit
Operating temperature	0 to +40	°C
Storage temperature	-20 to +70	°C

Amplifiers for photovoltaic detectors (Typ.)

Parameter	C4159-01	C4159-04	C4159-05	C4159-06	C4159-07	Unit
Applicable detector*1 *2 *3	Dewar type InSb (P5968-060, P5968-100) Dewar type InAsSb (P11120-901) Non-cooled type InAsSb (P13243-012CA, P13243-011MA) Non-cooled type InAsSb (P13894-011MA) TE-cooled type InAsSb (P13894-211MA)	Dewar type InSb (P5968-200)	Dewar type InAs (P7163)	TE-cooled type InAs (P10090-11/-21)	Non-cooled type InAs (P10090-01) TE-cooled type InAsSb (P11120-201, P12691-201)	-
Conversion impedance	$10^8, 10^7, 10^6$ (3 ranges switchable)	$2 \times 10^7, 2 \times 10^6, 2 \times 10^5$ (3 ranges switchable)	$10^8, 10^7, 10^6$ (3 ranges switchable)	$10^6, 10^5, 10^4$ (3 ranges switchable)		V/A
Frequency response (amp only, -3 dB)	DC to 100 kHz*4	DC to 45 kHz	DC to 15 kHz	DC to 100 kHz		-
Output impedance	50					Ω
Maximum output voltage (1 k Ω load)	+10			±10		V
Output offset voltage	±5		±10	±5		mV
Equivalent input noise current*5 (f=1 kHz)	0.15 ($10^8, 10^7$ range) 0.65 (10^6 range)	0.55	0.15 ($10^8, 10^7$ range) 0.65 (10^6 range)	6	10	pA/Hz ^{1/2}
Reverse voltage	Limited to 0 V operation					-
External power supply*6	±15					V
Current consumption	+30, -10 max.			+30, -22 max.		mA

Amplifiers for InGaAs PIN photodiodes (Typ.)

Parameter	C4159-03	Unit
Applicable detector*1 *2	InGaAs	-
Conversion impedance	$10^7, 10^6, 10^5$ (3 ranges switchable)	V/A
Frequency response (amp only, -3 dB)	DC to 15 kHz	-
Output impedance	50	Ω
Maximum output voltage (1 k Ω load)	+10	V
Output offset voltage	±5	mV
Equivalent input noise current (f=1 kHz)	2.5	pA/Hz ^{1/2}
Reverse voltage	Can be applied from external unit	-
External power supply*6	±15	V
Current consumption	±15 max.	mA

Note: Output noise voltage = Equivalent input noise current × Conversion impedance

- *1: These amplifiers cannot operate multiple detectors.
- *2: Consult us before purchasing if you want to use with a detector other than listed here.
- *3: Consult us before purchasing if you want to use with a multi-element detector.
- *4: When connected to a detector, frequency response becomes 60 kHz or less depending on the detector photosensitive area. ($\phi 0.6$ mm: 60 kHz or less, $\phi 1$ mm: 25 kHz or less) Ringing occurs in the output if the rise time t_r (0 to 90%) of incident light is approximately 100 μ s or less. The ringing becomes larger as the rise time becomes shorter. No ringing occurs when detecting sine-wave light. (For information on the ringing specifications, refer to the datasheet "Amplifier for infrared detector".)
- *5: Input resistance: 1 M Ω (C4159-01/-04/-05), 500 Ω (C4159-06/-07)
- *6: Recommended DC power supply (analog power supply): $\pm 15\text{ V}$
Current capacity: More than 1.5 times the maximum current consumption
Ripple noise: 5 mVp-p or less

Amplifiers for photoconductive detectors (Typ.)^{*7}

Parameter	C5185-02	Unit
Applicable detector ^{*8 *9 *10}	InSb (P6606 series)	-
Input impedance	5	kΩ
Voltage gain	66 (× 2000)	dB
Frequency response (amp only, -3 dB)	5 Hz to 250 kHz	-
Detector bias current	5 mA, 10 mA, 15 mA (3 ranges switchable)	-
Output impedance	50	Ω
Maximum output voltage (1 kΩ load)	±10	V
Equivalent input noise voltage (f=1 kHz)	2.6 ^{*11}	nV/Hz ^{1/2}
External power supply ^{*12}	±15	V
Current consumption	+100, -30 max.	mA

Note: Output noise voltage = Equivalent input noise voltage × Voltage gain

^{*7}: Before purchasing, make sure the bias current to the detector matches the detector bias current specified in the above table.

^{*8}: These amplifiers cannot operate multiple detectors.

^{*9}: Consult us before purchasing if you want to use with a detector other than listed here.

^{*10}: Consult us before purchasing if you want to use with a multi-element detector.

^{*11}: At the maximum detector bias current

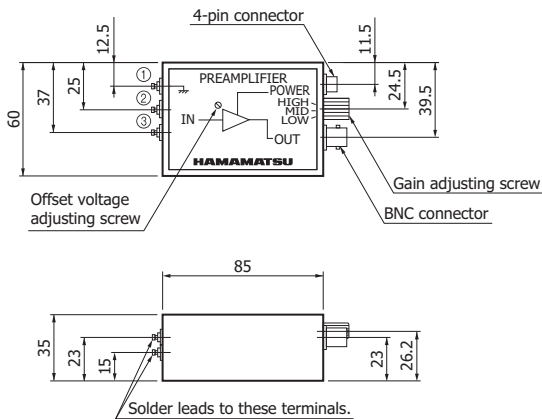
^{*12}: Recommended DC power supply (analog power supply): ±15 V

Current capacity: More than 1.5 times the maximum current consumption

Ripple noise: 5 mVp-p or less

Dimensional outlines (unit: mm, tolerance unless otherwise noted: ±1)

C4159-01/-03/-04/-05/-06/-07



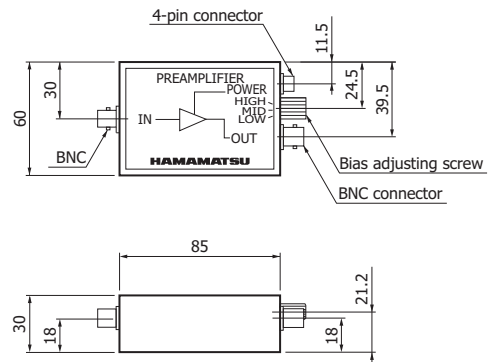
Pin connections

- ① GND
- ② Cathode
- ③ Anode

Note: Socket for lead attachment is not provided.

KIRDA0046EC

C5185-02



KIRDA0048EA

Description of terms

- **Dark resistance: R_D**

This is the resistance of a photoconductive detector in the dark state.

- **Dark current: I_D**

The dark current is the small current which flows when a reverse voltage is applied to a photovoltaic detector (InGaAs, InAs, InSb, etc.) under dark conditions. This is a factor for determining the lower limit of light detection.

- **FOV (field of view)**

The field of view is related to the background radiation noise and greatly influences the value of D^* .

- **Offset voltage**

This is DC output voltage of an amplifier when the input signal is zero.

- **Photosensitivity: S**

This is the detector output per watt of incident light at a given wavelength. The unit is usually expressed in V/W for photoconductive and in A/W for photovoltaic detectors. For photon drag detectors, this is represented as the output voltage with respect to incident pulsed energy of 1 kW radiated from a CO₂ laser.

- **Photovoltaic detector (photodiode)**

This is a semiconductor detector that generates electrical current or voltage when light enters its PN junction. Detector materials include InGaAs, InAs, InAsSb, and InSb.

- **Photoconductive detector**

This is a semiconductor detector whose conductivity increases with increasing incident light.

- **Peak sensitivity wavelength: λ_p**

This is the wavelength at which the sensitivity of the detector is at maximum.

- **Reverse voltage (max.): V_R max, supply voltage**

Applying a reverse voltage to a photovoltaic detector (or applying a voltage to a photoconductive detector) triggers a breakdown at a certain voltage and causes severe deterioration of the detector performance. Therefore the absolute maximum rating for the voltage is specified at the voltage somewhat lower than this breakdown voltage. Do not apply a voltage higher than the maximum rating.

- **Allowable current (max.)**

This is a maximum value of current which can be used when photoconductive detectors are operated. When the supply current is higher than the maximum allowable current, the detector performance may deteriorate, therefore, excessive current must be avoided.

- **NEP (noise equivalent power)**

This is the radiant power that produces S/N of 1 at the detector output. At HAMAMATSU we list the NEP measured at the peak sensitivity wavelength (λ_p). Since the noise level is proportional to the square root of the frequency bandwidth, the NEP is normalized to a bandwidth of 1 Hz.

$$\text{NEP [W/Hz}^{1/2}] = \frac{\text{Noise current [A/Hz}^{1/2}]}{\text{Photosensitivity [A/W] at } \lambda_p}$$

- **Cutoff frequency: f_c**

This is the frequency at which the output decreases 3 dB from the steady output level. The cutoff frequency (f_c) is related to rise time (t_r : time required for the output to rise from 10% to 90% of the maximum output value) as follows:

$$t_r [\text{s}] = \frac{0.35}{f_c [\text{Hz}]}$$

- **Rise time: t_r**

This is the value of a detector time response to a stepped light input, and defined as the time required for transition from 10% to 90% (or 0 to 63%) of the maximum (constant) output value. The light sources used are GaAs LED (0.92 μm), laser diode (1.3 μm), etc.

- **Terminal capacitance: C_t**

An effective capacitor is formed at the PN junction of a photovoltaic detector. Its capacitance is termed the junction capacitance and is one of the parameters that determine the response speed of the photovoltaic detector. And it can cause the phenomenon of gain peaking in I-V conversion circuit using op amp. In Hamamatsu, the terminal capacitance including this junction capacitance plus package stray capacitance is listed.

- **Short circuit current: I_{sc}**

The short circuit current is the output current which flows when the load resistance is 0 and is nearly proportional to the device photosensitive area. This is often called "white light sensitivity" with regards to the spectral response. This value is measured with light from a tungsten lamp of 2856 K distribution temperature (color temperature), providing 100 lx illuminance.

- **Cutoff wavelength: λ_c**

This represents the long wavelength limit of spectral response and in datasheets is listed as the wavelength at which the sensitivity becomes 10% of the value at the peak sensitivity wavelength.

- **Chopping frequency**

In the measurement of infrared detector sensitivity, an optical chopper is often used to perform on-off operation of incident light. This is the frequency of the chopper.

- **D^* (D-star: Detectivity)**

D^* is the detectivity indicating the S/N in an AC signal obtained by a detector when radiant energy of 1 W is input to the detector. D^* is normalized to a detector area of 1 cm² and a noise bandwidth of 1 Hz, to allow comparing of characteristics of detector materials independent of the detector area. D^* is usually represented as D^* (A, B, C), in which A is the light source temperature [K] or wavelength [μm], B is the chopping frequency [Hz], and C is the noise bandwidth [Hz]. D^* is expressed in units of $\text{cm} \cdot \text{Hz}^{1/2}/\text{W}$, and the higher the D^* , the better the detector. D^* is given by the following equation.

$$D^* = \frac{S/N \cdot \Delta f^{1/2}}{P \cdot A^{1/2}}$$

where S is the signal, N is the noise, P is the incident energy in [W/cm²], A is the photosensitive area in [cm²] and Δf is the noise bandwidth in [Hz]. The following relation is established by D^* and NEP:

$$D^* = \frac{A^{1/2}}{\text{NEP}}$$

- **Noise: N**

The noise is the output voltage from a photoconductive detector operated under specified conditions and 300 K background radiations.

- **Shunt resistance: R_{sh}**

This shunt resistance is the voltage-to-current ratio in the vicinity of 0 V in photovoltaic detectors and defined as follows: Where I_D is the dark current at reverse voltage=10 mV.

$$R_{sh} [\Omega] = \frac{10 [\text{mV}]}{I_D [\text{A}]}$$

For applications where no reverse voltage is applied, noise resulting from the shunt resistance becomes predominant.

- **Quantum efficiency: QE**

The quantum efficiency is the number of electrons or holes that can be detected as a photocurrent, divided by the number of incident photons. This is commonly expressed in percent [%]. The quantum efficiency and photosensitivity S have the following relationship at a given wavelength [nm]:

$$QE = \frac{S \times 1240}{\lambda} \times 100 [\%]$$

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